



Gases Japan TC Chapter and Facilities Japan TC Chapter Joint Meeting Meeting Summary and Minutes

SEMI Japan Standards Spring 2017 Meetings

March 24, 2017, 15:00-17:00

SEMI Japan, Tokyo, Japan

TC Chapter Announcements

Gases Japan TC Chapter:

SEMI Japan Standards Summer 2017 Meetings

Friday, June 23, 2017, 15:00-17:00

SEMI Japan, Tokyo, Japan

Facilities Japan TC Chapter:

SEMI Japan Standards Summer 2017 Meetings

Friday, June 23, 2017, 15:00-17:00

SEMI Japan, Tokyo, Japan

Table 1 Meeting Attendees

Co-Chairs of Gases Japan TC Chapter: Hiromichi Enami (Hitachi High Technologies), Isao Suzuki (MKS Japan)

Co-Chairs of Facilities Japan TC Chapter: Hiromichi Enami (Hitachi High Technologies), Isao Suzuki (MKS Japan)

SEMI Staff: Naoko Tejima (SEMI Japan)

<i>Company</i>	<i>Last</i>	<i>First</i>	<i>Company</i>	<i>Last</i>	<i>First</i>
Hitachi High Technologies	Enami	Hiromichi	Tokyo Electron Yamanashi	Moriya	Shuji
Tri Chemical Laboratories Inc.	Hiraki	Tadaaki	HORIBA STEC	Shimizu	Tetsuo
Fujikin	Hirose	Takashi	MKS Japan	Suzuki	Isao
Hitachi Metals	Jinbo	Katsuhiko	SEMI Japan	Tejima	Naoko
Fujikin	Kitano	Masashi			

** alphabetical order by last name*

Table 2 Leadership Changes

Gases Japan TC Chapter

None.

Facilities Japan TC Chapter

None.

Table 3 Ballot Results

Gases Japan TC Chapter

None.

Facilities Japan TC Chapter

None.

**Table 4 Authorized Activities
Gases Japan TC Chapter**

None.

Facilities Japan TC Chapter

None.

**Table 5 Authorized Ballots
Gases Japan TC Chapter**

None.

Facilities Japan TC Chapter

None.

**Table 6 New Action Items
Gases Japan TC Chapter**

None.

Facilities Japan TC Chapter

None.

**Table 7 Previous Meeting Action Items
Gases Japan TC Chapter**

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
Gas161213-1	SEMI Staff	To watch the progress of <i>Doc.5155, New Standard, Guide for Facilities Data Package for Semiconductor Equipment Installation</i> by Building Information Modeling (BIM) for Semiconductor Capital Equipment TF of NA ... Open

Facilities Japan TC Chapter

None.

[Common Part 1]

1 Welcome, Reminders, and Introductions

Isao Suzuki, committee co-chair, called the meeting to order at 15:00. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

2 Review of Previous Meeting Minutes

The TC Chapter reviewed the minutes of the previous meeting.

Motion: To approve the minutes of the previous meeting as written.

By / 2nd: Tetsuo Shimizu (HORIBA STEC) / Shuji Moriya (Tokyo Electron Yamanashi)

Discussion: None

Vote: 7 in favor and 0 opposed. **Motion passed.**

Attachment: 01_JA_G+F_Previous_Mtg_Minutes_170324

3 SEMI Staff Report

Naoko Tejima gave the SEMI staff report. This report included SEMI Global 2017 Calendar of Events, Global Standards Meeting Schedule, North America Standards Spring 2017 Meetings, 2017 Critical Dates for SEMI Standards Ballots, A&R Ballot Review, SEMI Standards Publication, PPT Template Updates, JRSC Organization Chart, SEMI TSUSHIN Information, Global Staff Assignment and Staff Contact Information.

Attachment: 02_SEMI_Staff_Report_170324

4 Liaison Reports

4.1 Facilities North America TC Chapter

Naoko Tejima reported for the Facilities North America TC Chapter that no report was provided, since there were not particular and updated things.

4.2 Gases North America TC Chapter

Naoko Tejima reported for the Gases North America TC Chapter that no report was provided, since there were not particular and updated things.

4.3 Gases Europe TC Chapter Report

Naoko Tejima reported for the Gases EU TC Chapter that no report was provided, since there were not particular and updated things.

4.4 Facilities Korea TC Chapter Report

Naoko Tejima reported for the Facilities Korea TC Chapter that no report was provided, since there were not particular and updated things.

[Gases Japan TC Chapter Part]

5 Subcommittee and Task Force Reports

5.1 Gas Panel and Metal Seal Test Methods Task Force

Shuji Moriya reported for the Gas Panel and Metal Seal Test Methods Task Force that there were not particular activities.

5.2 5-year-review Task Force

No Report was provided.

5.3 Live Gas Flow Rate Task Force

Tetsuo Shimizu reported for the Live Gas Flow Rate Task Force. The Task Force met earlier in the day. Of note:

- A round-robin test between MFC makers with critical nozzle was made and all test was finished, and the results were reviewed.
- The next step will be discussed at the next meeting.

6 Old Business

6.1 Previous Meeting Action Items

Naoko Tejima reviewed the previous meeting action items.

Table 8 Previous Meeting Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
Gas161213-1	SEMI Staff	To watch the progress of <i>Doc.5155, New Standard, Guide for Facilities Data Package for Semiconductor Equipment Installation</i> by Building Information Modeling (BIM) for Semiconductor Capital Equipment TF of NA ... Open

7 New Business

None.

[Facilities Japan TC Chapter Part]

8 Task Force Reports

8.1 F1 Revision Task Force

No Report was provided.

9 Old Business

9.1 Previous Meeting Action Items

Naoko Tejima reviewed the previous meeting action items.

Table 9 Previous Meeting Actions Items

None.

10 New Business

None.

[Common Part 2]

11 Action Item Review

11.1 New Action Items

Naoko Tejima reviewed the new action items. These can be found in the New Action Items table at the beginning of these minutes.

12 Next Meeting and Adjournment

The next meeting of the Gases Japan TC Chapter is scheduled for Friday, June 23, 2017, 15:00-17:00, SEMI Japan, Tokyo, Japan.

The next meeting of the Facilities Japan TC Chapter is scheduled for Friday, June 23, 2017, 15:00-17:00, SEMI Japan, Tokyo, Japan.

See <http://www.semi.org/en/events> for the current list of meeting schedules.

Having no further business, a motion was made to adjourn. Adjournment was at 17:00.



Respectfully submitted by:
Naoko Tejima
Manager, Standards
SEMI Japan
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Minutes approved by:

Hiromichi Enami (Hitachi High Technologies), Co-chairs	June 13, 2017
Isao Suzuki (MKS Japan), Co-chairs	June 12, 2017

Table 10 Index of Available Attachments #1

#	<i>Title</i>
1	JA_G+F_Previous_Mtg_Minutes_170324
2	SEMI_Staff_Report_170324

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact Naoko TEJIMA at the contact information above.